

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : EXPEDITED PROCEDURE
: Response under 37 CFR 1.116

Pierre-Olivier LEFORT et al. : Confirmation No. 6495

U.S. Patent Application No. 10/510,385 : Group Art Unit: 2813

Filed: October 6, 2004 : Examiner: Thanh T. NGUYEN

For: PROCESS FOR FABRICATING A MICROSTRUCTURE CONTAINING A VACUUM CAVITY, AND MICROSTRUCTURE

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.116

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Commissioner for Patents
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Sir:

This paper is submitted in reply to the Office Action mailed September 18, 2007, which was made Final. Applicants respectfully request that the following amendments **as to form** be entered to place this application in condition for allowance.

Amendments to the Claims - page 2 of this paper.

Remarks/Arguments - page 5 of this paper.